

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Teruhito OHNISHI, et al. :
Serial No.: Divisional of : Group Art Unit: To be assigned
Application No. 10/061,365 :
Filed: July 17, 2003 : Examiner: To be assigned
For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD OF THE
SAME

PRELIMINARY AMENDMENT

Mail Stop NEW APPLICATIONS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows: